



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**International U.S. Patent Application of**

**YOKOGAWA et al.**

**Application Number: 09/939,770**

**Filed: August 28, 2001**

**For: METHOD FOR MANUFACTURING  
A SEMICONDUCTOR DEVICE**

**Attorney Docket No. NITT.0030**

**Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231**

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) **Art Unit 1765**  
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) **Examiner**  
) **Powell, William A.**  
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**RESPONSE AND AMENDMENT UNDER 37 C.F.R. §1.111**

Sir:

This is in response to the office action dated February 26, 2003, in the above identified application, to which the period for response will expire on August 26, 2003, with a three-month extension fee filed herewith. Please amend the above identified application as follows: